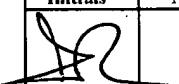
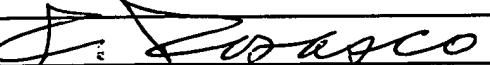


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				Application Number	10/510,916
				Confirmation Number	7320
				Filing Date	October 12, 2004
				First Named Inventor	Shinichi ISHIBASHI
				Art Unit	2812
				Examiner Name	Not yet assigned
Sheet		1	of	1	Attorney Docket Number
					Q84137

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		SHINJI TSUBOI, et al., Recent progress in 1Xx-ray mask technology: Feasibility Study using ASET-NIST format TaXN x-ray masks with 100 nm rule 4 Gbit dynamic random access memory test patterns, 2001 American Society, pgs. 2416-2422.			
		M. TAKAHASHI, et al., Smooth, low-stress, sputtered tantalum and tantalum alloy films for the absorber material of reflective-type EUVL, In Emerging Lithographic Technologies IV, Elizabeth A. Dabisz, Editor, Proceedings of SPIE Vol. 3997 (2000), pgs. 484-495.			
		KENNETH RACETTE, et al., Sputter deposition and annealing of Ta, TaSi _X and TaB _X composite films and their application in next generation lithography masks, 2000 American Vacuum Society, pgs. 1119-1124.			

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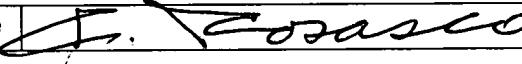
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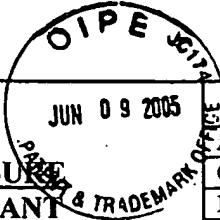
J. Rosasco

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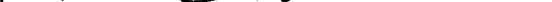
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Application Number 10/510,916 Confirmation Number 7320 Filing Date October 12, 2004 First Named Inventor Shinichi ISHIBASHI Art Unit 2812 Examiner Name Not yet assigned				

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